

**APPLICATION TRANSFER REQUEST FOR**

10/040,272

**Section I. TRANSFER REQUEST BY** (PRINT NAME) Q. Leung

Date: 7/30/02

TO: AU 3742 Class 219/686+ FROM: AU 2828, Class 372

**REASON:**

**System and process for heating semiconductor wafers. Note related US patents 4622447, 4517026 and 5219798.**

Gatekeeper concurrence \_\_\_\_\_

Hand carried: Personally accepted by \_\_\_\_\_

**Section II a. DISPOSITION BY RECEIVING TC** By: J Walberg A.U. 3742 Date 8/1/02

☒ **ACCEPTED BY RECEIVING T.C.**

**NOT ACCEPTED**

☐ Non-classification issue/other, return to Originating TC/AU \_\_\_\_\_

**REASON:**

**Section II b. DISPOSITION BY RECEIVING TC POST CLASSIFIER**

☐ This dispute was resolved. Forward to \_\_\_\_\_

Concurring \_\_\_\_\_ Date \_\_\_\_\_

☐ This dispute was not resolved, forward to DISPUTE RESOLUTION PANEL

**Post Classifier Assessment:**

Gatekeeper Concurrence \_\_\_\_\_

Post Classifier \_\_\_\_\_

**Section III. DISPOSITION BY DISPUTE RESOLUTION PANEL**

Date \_\_\_\_\_

**Panel Decision:**

**REASON:**

Panel Member \_\_\_\_\_ Concurring Panel Member \_\_\_\_\_

☐ This application **MAY NOT** be returned to the dispute resolution panel. **THIS IS A FINAL DISPOSITION.**